

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10567792
<b>Filing Date:</b>	09-Feb-2006
<b>Title of Invention:</b>	Method of processing substrate and substrate processing apparatus
<b>First Named Inventor/Applicant Name:</b>	Katsuyoshi Nakatsukasa
<b>Filer:</b>	Kenneth H. Salen./Renita Flood
<b>Attorney Docket Number:</b>	062032

Filed as Large Entity

### **U.S. National Stage under 35 USC 371 Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Request for continued examination	1801	1	810	810
<b>Total in USD (\$)</b>				<b>810</b>